## 502021422 08/10/2012

# PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

| SUBMISSION TYPE:      | NEW ASSIGNMENT |
|-----------------------|----------------|
| NATURE OF CONVEYANCE: | ASSIGNMENT     |

#### **CONVEYING PARTY DATA**

| Name           | Execution Date |
|----------------|----------------|
| Mitsufumi NAOE | 07/25/2012     |

## **RECEIVING PARTY DATA**

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| Postal Code:    | 222-0033                         |  |

## PROPERTY NUMBERS Total: 1

| Property Type       | Number   |  |
|---------------------|----------|--|
| Application Number: | 13571699 |  |

#### **CORRESPONDENCE DATA**

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Total Attachments: 1

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PATENT REEL: 028769 FRAME: 0376 OP \$40.00 13571699

# U.S. ASSIGNMENT

IN CONSIDERATION of the sum of One Dollar (\$1.00), and of other good and valuable consideration paid to the undersigned inventor(s) (hereinafter, "ASSIGNOR") by (Insert Name(s) & Address(es) of ASSIGNEE(S))

| FUJITSU SEMICONDUCTOR LIMITED   |  | Washington and the same of the |
|---|--|--|
| 2-10-23 Shin-Yokohama, Kohoku-Ku Yoko   | hama-shi, Kanagawa 222-0033 Japan  |  |
| And the second second control of the second |  |  |
| (hereinafter, "ASSIGNEE"), the rehereby sells, assigns and transfe<br>to the invention entitled   | ceipt of which is hereby acknowers to ASSIGNEE the entire and e  | ledged, the undersigned ASSIGNOR<br>xclusive right, title and interest   |
| (Title of Invention)  |  |  |
| METHOD FOR PRODUCING SEMICONDUCTOR DEVICE   | E AND SEMICONDUCTOR DEVICE   |  |
|   |  |  |
|   | t Nametan  |  |
| relating to International Patent<br>Letters Patent of the United Stat   | Application PCT/JP/<br>es was executed on even date he   | and/or for which application for rewith or, if not so executed, was:   |
| (a) executed on   | (Insert date of execution  | of application, if not concurrent)   |
| (b) filed on  |  |  |
| Serial No.  |  | ney is hereby authorized to insert<br>ed data, when known.   |
| and to said application and all L and any continuation, division, r thereon, for the full term or terincluding any extensions thereof Patent(s)").  | enewal, substitute, reissue or ms for which the said Letters P   | atent(s) may be granted and  |
| said ASSIGNEE, to do all acts whi<br>securing, maintaining and enforci  | ch the ASSIGNEE may deem necess<br>ng protection for said inventio<br>) and the issuance of said Lett<br>use proceeding, and in any lit<br>relation to same, such acts to<br>eparate assignments and declara | n, including in the preparation and<br>ers Patent(s), in any interference,<br>igation or other legal proceeding<br>include but not be limited to   |
| IN WITNESS WHEREOF, the undersi   | gned inventor(s) has (have) aff  | ixed his/her/their signature(s).   |
| 1) 直江光史   | MITSUFUMI NAOE   | July. 25, 2012   |
| ( Signature)  | ( Type Name)   | ( Date)  |